033082M298



Applicant(s): Tsuneyuki OKABE, et al.

U.S. Serial No.: 10/564,558

Group Art Unit: 2812

Filed: : January 13, 2006

Examiner: To Be Assigned

For:

SEMICONDUCTOR MANUFACTURING APPARATUS AND

SEMICONDUCTOR MANUFACTURING METHOD

SIXTH INFORMATION DISCLOSURE STATEMENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the references cited in the attached Notice of Allowance and Search Report issued on September 12, 2008 for Taiwanese Patent Application No. 93121383.

Applicants certify under 37 C.F.R. 1.97(e)(1) that all documents submitted herewith were cited in a communication from a foreign patent office in a counterpart foreign application no more than three months prior to the filing of this Statement. Therefore, it is respectfully urged that no fees are required for the Examiner's consideration of the documents listed in this Information Disclosure Statement.

A Notice of Allowance on the merits has issued for this application. In accordance with the requirements of 37 C.F.R. §1.97(d), Applicants attach a check for \$180.00 in payment of the requisite fee (37 CFR §1.17(p)). It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

> Respectfully submitted, SMITH, GAMBRELL & RUSSELL, LLP

By:

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